PETITION	FOR EXTENSION OF TIN (Large Entit		CFR 1.136(a)	Docket No. 149-01
In Re Application	ion Of: Michio Horiuchi	FEB 0 2 2004	024	
Serial No 09/881,005		Demarucki Demarucki	Examiner Oouglas W. Owens	Group Art Unit 2811
Invention: M	lulti-Layered Semiconductor Devi	ce and Method for F	Producing the Same	# 16 EOT C
			NER FOR PATENTS:	3/5/
of <u>S</u>	st under the provisions of 37 CFF September 30, 2003 above-identife Date extension is as follows (check tire	fied application.		sponse to the Office Action
⊠ One r	<u></u>	☐ Three mont	_	s 🔲 Five months
from:	December 30, 2003	until:	January 30, 2	2004
☑ A check☐ The Come overpaynthA duplication☑ If an addition any addition		osed. to charge any fees v d. ired, please considered to Deposit Accour	er this a petition therefor a int No. 16-0750	1 1 20
Paul & Paul	isand Market St. A 19103		on first class mail under 37	cument and fee is being deposited with the U.S. Postal Service a 7 C.F.R. 1.8 and is addressed to the for Patents, Washington, D.C.
¢:1251	110.00 OP		Signature of Per	rson Mailing Correspondence
cc:			Tuned on Britand Nove	e of Person Mailing Correspondence